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	Filing Date		2006-09-15
	First Named Inventor	Peng-Fei Fu	
	Art Unit	1762	
	Examiner Name	Unknown	
	Attorney Docket Number	071038.00102	

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	3	LABIANCA ET AL., "High Aspect Ratio Resist For Thick Film Applications", Advances In Resist Technology and Processing XII, Spie, 1995, Vol. 2438, pages 846-852, XP002437324.	<input type="checkbox"/>
	4	MATSUI ET AL., "Room-temperature nanoimprint and nanotransfer printing using hydrogen silsequioxane", Journal of Vacuum Science & Technology B: Microelectronics Processing and Phenomena, American Vacuum Society, March 2003, Vol. 21, No. 2, pages 688-692, XP012009826.	<input type="checkbox"/>
	5	PFEIFFER ET AL., "Reactive Polymers - a Route to Nanoimprint Lithography at Low Temperatures", Proceedings of Spie, Spie, 2003, Vol 5037, pages 203-210, XP-002297929.	<input type="checkbox"/>
	6	PFEIFFER ET AL., "Multistep profiles by mix and match of nanoprint and UV lithography", Microelectronic Engineering, 2001, Vol. 57-58, pages 381-387, XP004302289.	<input type="checkbox"/>
	7	SUN XIAOYUN ET AL., "Multilayer resist methods for nanoimprint lithography on nonflat surfaces", Journal of Vacuum Science & Technology B: Microelectronics Processing and Phenomena, American Vacuum Society, 1998, Vol. 16, No. 6, pages 3922-3925, XP012007311.	<input type="checkbox"/>
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